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Appl. No. 10/734,419

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. ....10/734,419  
Filing Date ..... December 11, 2003  
Inventor ..... John T. Moore et al.  
Assignee ..... Micron Technology, Inc.  
Examiner ..... Warren, Matthew E.  
Group Art Unit ..... 2815  
Customer No. ....021567  
Attorney Docket No. ....MI22-2463  
Title: Semiconductor Wafer Assemblies Comprising Photoresist Over Silicon Nitride  
Materials

**RESPONSE TO MAY 9, 2005 OFFICE ACTION**

To: Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

From: Jennifer J. Taylor, Ph.D. (Tel. 509-624-4276; Fax 509-838-3424)  
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**AMENDMENTS**

**Introductory Comments**

In reply to the office action dated May 9, 2005, applicant amends and remarks as follows.